

Procedural Review Voting Sheet

Auxiliary Information not Published with a Standard or a Safety Guideline (Independently Published Auxiliary Information)

2013 Cycle 2

REGION: **NA**
 COMMITTEE: Silicon Wafer
 EVENT: **NA Spring**
 DATE OF MEETING: April 2, 2013
 PLACE OF MEETING: Intel in Santa Clara, CA
 COMMITTEE CO-CHAIRS: Dinesh Gupta (STA) and Noel Poduje (SMS)
 SEMI STAFF: Kevin Nguyen

A&R Voter: Name/Company
 Date: 200X/MM/DD

I. Document Number & Title

Doc. 5559	New Auxiliary Information: Interlaboratory Evaluation Of Nondestructive Method For Measuring The Edge Contour Of Silicon Wafers
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1. Committee Vote

Auxiliary information is not intended to be published with a standard or safety guideline. It may be authorized for publication as a separate document by a two-thirds majority of persons voting on the action during a scheduled meeting of a technical committee (see ¶ 7.2.3 for a discussion of when interest voting may be called for), and subsequent approval by both the coordinating subcommittee and the ISC A&R SC.(SEMI Regulations 13.2.3)

Accepts	7	
Rejects	0	

Total Votes	7	
Accept %	100%	

2. Safety Check

See Section 14 of the SEMI Regulations for further information

Motion:	<input checked="" type="checkbox"/>	This is not a Safety Document: when all safety-related information is removed, the document is still technically sound and complete.
	<input type="checkbox"/>	This is a Safety Document: when all safety-related information is removed, the document is not technically sound and complete. Safety documents CANNOT be published as Preliminary Standards.
Motion by/ 2nd by		Mike Goldstein (Intel)/George Kren (KLA-Tencor)
Discussion		None
Vote		6-0 Motion passed
A&R	<input type="checkbox"/>	Not approved
	<input type="checkbox"/>	Reason:

3. Intellectual Property Check

Note: This ballot may be all or part of a Standard or Safety Guideline. This IP check applies to the entire Standard or Safety Guideline. See § 15 of the Regulations for further information

x	The meeting chair asked those present in person or by electronic link, if they were aware of any potentially material patented technology or copyrighted items* in the Standard or Guideline.	
x	No potentially material patented technology or copyrighted items are known	GO TO SECTION IX
	Potentially material patented technology or copyrighted items are known but a Letter of Assurance (LOA) or copyright release for such material has been obtained or presented to the committee.	GO TO SECTION IX
	Potentially material patented technology or copyrighted items are known but an LOA or copyright release for some of the material(s) has NOT been obtained or presented to the committee	
MOTION	<input type="checkbox"/>	Ask ISC for special permission to publish
	<input type="checkbox"/>	Quit activity
	<input type="checkbox"/>	Wait for LOA for patented technology or release of copyrighted items.
	Motion by/2nd by	Name (Company)/Name (Company)
	Discussion	XXXX
	Vote	XX-XX
	Final Action	<input type="checkbox"/> Motion Passed
		<input type="checkbox"/> Motion Failed
A&R	<input type="checkbox"/>	Not approved
	Reason:	

* Note: Such potentially material patented technology or copyrighted items might have become known since the Standard or Safety Guideline was last reviewed, or might become relevant due to this ballot.

4. Action for this document

Motion	<input checked="" type="checkbox"/>	This document passed committee review and will be forwarded to the GCS for their approval
	<input type="checkbox"/>	This document failed committee review and will be returned to the task force for rework.
	<input type="checkbox"/>	This document failed committee review and will be discontinued.
	Motion by/ 2nd by	Mike Goldstein (Intel)/George Kren (KLA-Tencor)
	Discussion	Tetsuya Nakai discussed that the consensus of the Int'l Test Methods TF should be consulted prior to approving as an auxiliary document. Kevin Nguyen stated that a copy was sent to all Silicon Wafer members a few weeks prior. The document was published since 1993, but was misplaced by SEMI when acquired in 2003. A copy was still kept by Bob Landman, one of the ASTM volunteers. In order to secure in the SEMI publication, the committee would like to approve as auxiliary information.
	Vote	7-0
	Final Action	<input checked="" type="checkbox"/> Motion passed
		<input type="checkbox"/> Motion failed

A&R	Not approved
	Reason:

5. GCS Review

Method of review	<input checked="" type="checkbox"/>	Vote conducted via email
	<input type="checkbox"/>	Vote conducted via teleconference.
	<input type="checkbox"/>	Vote conducted at face-to-face meeting
Discussion		None
Vote		6-0
Final Action		<input checked="" type="checkbox"/> Approved by the GCS and will be forwarded to the A&R for procedural review.
		<input type="checkbox"/> Not approved
A&R	Approved	
	Not approved	
	Reason:	